

<b>Notice of References Cited</b>	Application/Control No. 10/539,572		Applicant(s)/Patent Under Reexamination VIELLEROBE ET AL.	
	Examiner David N. Werner		Art Unit 2621	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-			
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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